

10/544084

Our ref: KON-2020

Client's ref: P6636-001-0000 (US)

JC20 Rec'd PCT/PTO 28 JUL 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

-----X

In re Application of :  
Hiromoto, II, et al

International Application No. :  
PCT/JP2004/010085

International Filing Date: 8 July 2004: Dated: July 28,  
2005

Title : FILM FORMING METHOD AND :  
SUBSTRATE HAVING A FILM  
FORMED BY THE METHOD :  
-----X

PRELIMINARY AMENDMENT

Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

S i r:

Attached are Specification Amendments, Claim  
Amendments, and Remarks, each starting on a separate page.